

Notice of References Cited	Application/Control No. 10/826,038		Applicant(s)/Patent Under Reexamination MABUCHI ET AL.	
	Examiner CHIA-WEI A. CHEN		Art Unit 2622	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,907,357	05-1999	Maki, Yasuhiro	348/312
*	B	US-6,054,704	04-2000	Pritchard et al.	250/208.1
*	C	US-5,933,188	08-1999	Shinohara et al.	348/302
*	D	US-6,512,543	01-2003	Kuroda et al.	348/302
*	E	US-7,224,391	05-2007	Kimura, Hajime	348/310
*	F	US-6,522,365	02-2003	Levantovsky et al.	348/537
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U				
	V				
	W				
	X				

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.